



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al.

Group Art Unit: 1765

Application No.: 10/509,177

Filed: September 27, 2004

Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP
COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING
A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

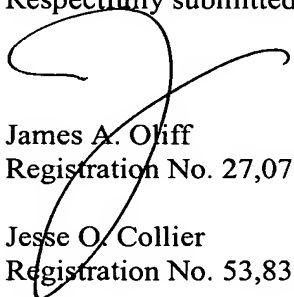
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. See References Nos. 1-8.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached hereto. See References Nos. 2-8.
- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See References Nos. 2-8.

Respectfully submitted,


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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 121213		APPLICATION NO. 10/509,177	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Akinori KOUKITSU et al.			
				FILING DATE September 27, 2004		GROUP 1765	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	1.	WO 01/38600 A1	05/31/2001	WIPO			
	2.	JP-A-2002-173393	06/21/2002	JAPAN	X	X	
	3.	JP-A-2000-223418	08/11/2000	JAPAN	X	X	
	4.	JP-A-2005-223243	08/18/2005	JAPAN	X	X	
	5.	JP-A-08-157299	06/18/1996	JAPAN	X	X	
	6.	JP-A-2000-031060	01/28/2000	JAPAN	X	X	
	7.	JP-A-2005-057196	03/03/2005	JAPAN	X	X	
	8.	JP-A-2001-313254	11/09/2001	JAPAN	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: March 3, 2006